

Docket No.: 60188-031



#7

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Kentaro SHIOMI, et al.

Serial No.: 09/779,440

Filed: February 09, 2001

For: LSI DESIGN METHOD AND VERIFICATION METHOD

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: Group Art Unit:
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: Examiner:
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INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
Washington, DC 20231

Dear Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the documents listed on the attached form PTO-1449. It is respectfully requested that the documents be expressly considered during the prosecution of this application, and that the documents be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is being filed within three months of the U.S. filing date OR before the mailing date of a first Office Action on the merits. No certification or fee is required.

Respectfully submitted,

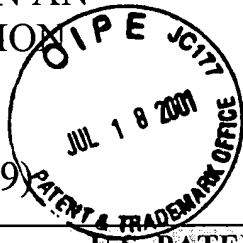
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INFORMATION DISCLOSURE
CITATION IN AN
APPLICATION

(PTO-1449)



ATTY. DOCKET NO.
60188-031

SERIAL NO.
09/779,440

APPLICANT
Kentaro SHIOMI , et al.

FILING DATE
February 09, 2001

GROUP

U.S. PATENT DOCUMENTS

EXAMINER'S INITIALS	PATENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE
	6,006,328	12/21/1999	Drake			
	5,014,311	5/7/1991	Schrenk			

FOREIGN PATENT DOCUMENTS

EXAMINER'S INITIALS	PATENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						Yes	No

OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)

EXAMINER

DATE CONSIDERED

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.